

Form PTO-1449

U.S. DEPARTMENT OF COMMERCE
PATENT AND TRADEMARK OFFICE

ATTY. DOCKET NO.
MI22-1372

SERIAL NO.
09/927,230

APPLICANT
Truong Tri Doan

FILING DATE
August 9, 2001

GROUP
1762

LIST OF ART CITED BY APPLICANT
(Use several sheets if necessary)

U.S. PATENT DOCUMENTS

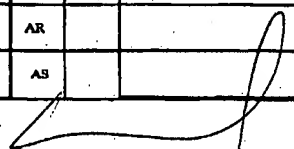
Examiner Initial	Document Number	Date	Name	Class	Subclass	Filing Date if Appropriate
	AA 6,479,902	11/2002	Lopatin et al			
	AB 6,458,416	10/2002	Derderian et al			
	AC 6,368,954	04/2002	Lopatin et al			
	AD 6,235,571	05/2001	Doan			
	AE 6,066,358	05/2000	Guo			
	AF 5,366,953	11/1994	Char et al			
	AG 5,273,930	12/1993	Steele et al			
	AH 6,114,099	09/2000	Liu et al			
	AI 2002/0125516	09/2002	Marsh et al			
	AJ					
	AK					

FOREIGN PATENT DOCUMENTS

	Document Number	Date	Country	Class	Subclass	Translation	
						Yes	No
AL							
AM							
AN							

OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)

AO		
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EXAMINER 

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EV085426511

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ATTY. DOCKET NO. MI22-1372
SERIAL NO. 09/927,330

APPLICANT Trung Thi Doan

FILING DATE August 9, 2001
GROUP 1762

U.S. PATENT DOCUMENTS

*Examiner Initial	Document Number	Date	Name	Class	Subclass	Filed for Appropriate
AA	4,913,090	04/1990	Harada et al			
AB	6,307,184	10/2001	Womack et al			
AC	5,616,208	04/1997	Lee			
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AK	6,335,561	03/2002	Sandhu et al			
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AP	Aarik, et al, "Control of Thin Film Structure by Reactant Pressure in Atomic Layer Deposition of TiO ₂ ," Journal of Crystal Growth, 169 (1996) pgs. 496-502
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EXAMINER *[Signature]* DATE CONSIDERED *10/26/07*

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